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APPLICANTS

Eiji Kamiyama, Tokyo, JAPAN;
 Takeo Katoh, Tokyo, JAPAN;
 Jea Gun Park, Seoul, KOREA, REPUBLIC OF;

**** CONTINUING DATA *******

This application is a 371 of PCT/JP04/04886 04/02/2004

**** FOREIGN APPLICATIONS *******

JAPAN 2003-099541 04/02/2003

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 5	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					

ADDRESS	
KUBOVCIK & KUBOVCIK SUITE 710 900 17TH STREET NW WASHINGTON, DC 20006	

TITLE	
	Laminated semiconductor substrate process for producing the same

FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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